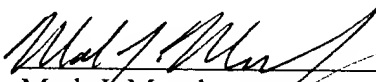


Applicants will also be submitted another IDS in the near future and request consideration of it prior to the issuance of any further action on this application.

Favorable consideration is earnestly solicited.

Respectfully submitted,

Date: August 26, 2002

  
Mark J. Murphy  
Registration No. 34,225

COOK, ALEX, McFARRON, MANZO,  
CUMMINGS & MEHLER, LTD.  
200 West Adams Street  
Suite 2850  
Chicago, Illinois 60606  
(312) 236-8500

Marked-up copy of the claims as amended:

IN THE CLAIMS:

Please amend the claims as follows:

1.(Amended) A film deposition apparatus comprising:

a stock chamber for loading or unloading a [substrata] substrate;

a transferring chamber including a mechanism for transferring said substrate; and

a liquid phase film deposition chamber connected to said transferring chamber through a gate,

wherein said liquid phase film deposition chamber is provided with a mechanism for oxidizing

an element belonging to Group 1 or 2 of the periodic table.

13.(Amended) A film deposition apparatus comprising:

a stock chamber for loading or unloading a [substrata] substrate;

a transferring chamber for transferring said substrate; and

an EL material deposition chamber connected to said transferring chamber through a gate,

wherein said EL material deposition chamber is provided with a cell which contains an

element belonging to Group 1 or 2 of the periodic table.

Cancel Claims 19-30.